



Image 2899

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
SUNGHO JIN ET AL.)
Application No.: 10/141,421)
Filed: 01/22/2002)
For: Optical Systems Comprising Curved)
MEMs Mirrors and Methods for Making)
Same)
Examiner: Mooney, Michael P.
Group Art Unit: 2899
Confirmation No.: 4756
January 30, 2004

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed January 22, 2004, please amend the
above-identified case as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 30, 2004

(Date of Deposit)

Alayne Geller

Alayne Geller

Alayne Geller

Signature

January 30, 2004

Date of Signature